Se	arch	rch Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
09/722,742	HENDRICKS, JOHN S.
Examiner	Art Unit
Yemane M. Gerezgiher	2144

Yemane M. Gerezgiher

	SEAR	CHED	
Class	Subclass	Date	Examiner
709	203,217	4/21/2005	YMG
709	219,229	4/21/2005	YMG
709	232 -	4/21/2005	YMG
345	744,745	4/21/2005	YMG
345	751,776	4/21/2005	YMG
345	901	4/21/2005	YMG
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
709	229	4/21/2005	YMG
345	745	4/21/2005	YMG
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Updated East keyword Search	4/21/2005	YMG
NPL search (CiteSeer, Google, IEEE)	4/21/2005	YMG
Consulted with Primary Examiner marc D. Thompson	4/21/2005	YMG
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